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## BIB DATA SHEET

CONFIRMATION NO. 5318

<b>SERIAL NUMBER</b> 10/823,970	<b>FILING or 371(c) DATE</b> 04/13/2004 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2892	<b>ATTORNEY DOCKET NO.</b> AMD-AFO1215
<b>APPLICANTS</b> Hiroyuki Ogawa, Sunnyvale, CA; Yider Wu, Campbell, CA; Nian Yang, Mountain View, CA; Kuo-Tung Chang, Saratoga, CA; Yu Sun, Saratoga, CA;				
<b>** CONTINUING DATA *****</b> <b>** FOREIGN APPLICATIONS *****</b> <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 06/24/2004				
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /QUOC DINH HOANG/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance QH Initials	<b>STATE OR COUNTRY</b> CA	<b>SHEETS DRAWINGS</b> 7	<b>TOTAL CLAIMS</b> 22
			<b>INDEPENDENT CLAIMS</b> 3	
<b>ADDRESS</b> SPANSION LLC C/O MURABITO , HAO & BARNES LLP TWO NORTH MARKET STREET THRID FLOOR SAN JOSE, CA 95113 UNITED STATES				
<b>TITLE</b> Semiconductor device having a pad metal layer and a lower metal layer that are electrically coupled, whereas apertures are formed in the lower metal layer below a center area of the pad metal layer				
<b>FILING FEE RECEIVED</b> 806	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	